

**Notice of References Cited**

Application/Control No.

10/526,077

Applicant(s)/Patent Under  
Reexamination  
KIM ET AL.

Examiner

MICHAEL FARAGALLA

Art Unit

2617

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
	C	US-			
	D	US-			
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	J	US-			
	K	US-			
	L	US-			
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**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP 1 071 264	01-2001	EP	Hashimoto et al	H04M 1/65
	O					
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	R					
	S					
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**NON-PATENT DOCUMENTS**

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